IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TANIGUCHI Atty. Ref.: 972-85

Serial No. To Be Assigned Group: Not Yet Assigned

Filed: August 30, 2001 Examiner: Not Yet Assigned

For: PROJECTION EXPOSURE APPARATUS AND METHOD

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August 30, 2001

Assistant Commissioner for Patents Washington, DC 20231

Sir:

PRELIMINARY AMENDMENT

In order to place the above-identified application in better condition for examination, please amend the application as follows:

IN THE SPECIFICATION

Page 1, before line 4 "BACKGROUND OF THE INVENTION", please insert the following paragraph:

This application is a divisional of U.S. Patent Application No. 09/263,803, filed March 8, 1999, now pending, which is a continuation of U.S. Patent Application No. 08/871,881, filed June 9, 1997, abandoned, the entire contents of which are hereby incorporated by reference in this application.

IN THE CLAIMS

Please cancel claims 13-31 without prejudice or disclaimer.

Please add new claims 32-40 as follows:

- 32. (New) The projection exposure apparatus of claim 1, wherein the projection optical system comprises a first lens element and a second lens element, the imagery characteristic correction mechanism having a first drive to drive the first lens element and a second drive to drive the second lens element.
- 33. (New) The projection exposure apparatus of claim 1, wherein the projection exposure apparatus is a scanning type projection exposure apparatus.
- 34. (New) The projection exposure apparatus of claim 9, wherein the projection optical system comprises a first lens element and a second lens element, the imagery characteristic correction mechanism having a first drive to drive the first lens element and a second drive to drive the second lens element.
- 35. (New) The projection exposure apparatus of claim 9, wherein the projection exposure apparatus is a scanning type projection exposure apparatus.
- 36. (New) A projection exposure apparatus that projects a pattern onto a substrate through a projection optical system, the projection exposure apparatus comprising:

an imagery characteristic correction mechanism coupled with the projection optical system that drives at least part of the projection optical system to correct an imagery characteristic of the projection optical system;

an error detector communicating with said imagery characteristic correction mechanism, said error detector determining a projection error of the pattern in accordance

with a driven amount of the projection optical system by said imagery characteristic correction mechanism; and

a correction mechanism connected to the error detector to correct the projection error.

- 37. (New) The projection exposure apparatus of claim 36, wherein the detector comprises a memory to store a relation between the driven amount the projection optical system and the projection error of the pattern.
- 38. (New) The projection exposure apparatus of claim 36, wherein the imagery characteristic correction mechanism comprises a plurality of actuators to drive at least part of the projection optical system.
- 39. (New) The projection exposure apparatus of claim 36, wherein the projection optical system comprises a first lens element and a second lens element, the imagery characteristic correction mechanism having a first drive to drive the first lens element and a second drive to drive the second lens element.
- 40. (New) The projection exposure apparatus of claim 36, wherein the projection exposure apparatus is a scanning type projection exposure apparatus.

REMARKS

Claims 1-12 and 32-40 are present in this application. By this Amendment, claims 13-31 have been canceled, and claims 32-40 have been added.

A prompt and favorable examination is requested.

Respectfully submitted,

NIXON & VANDERHYE P.C.

Alan M. Kagen

Reg. No. 36,178

AMK:jls

1100 North Glebe Road, 8th Floor

Arlington, VA 22201-4714

Telephone: (703) 816-4000 Facsimile: (703) 816-4100

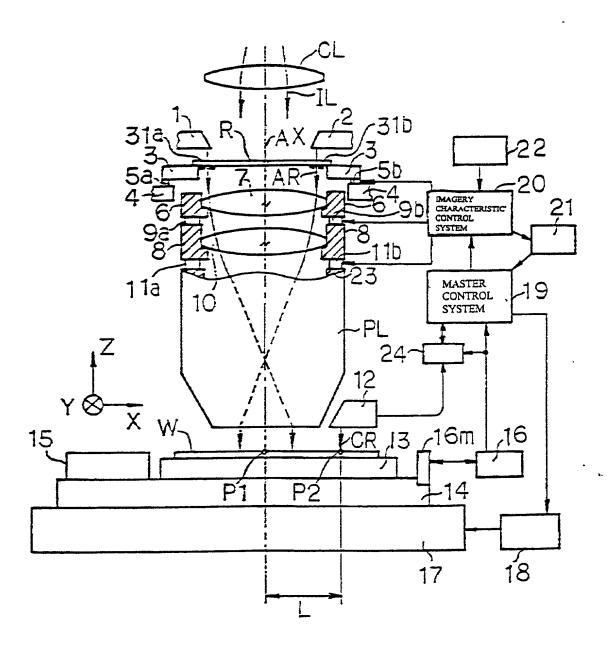


FIGURE 1

FIGURE 2

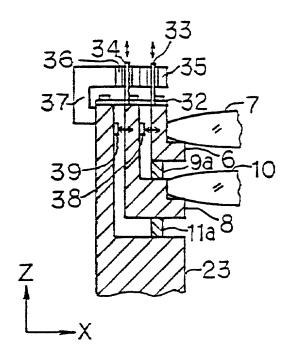
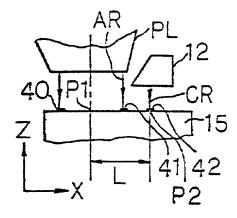
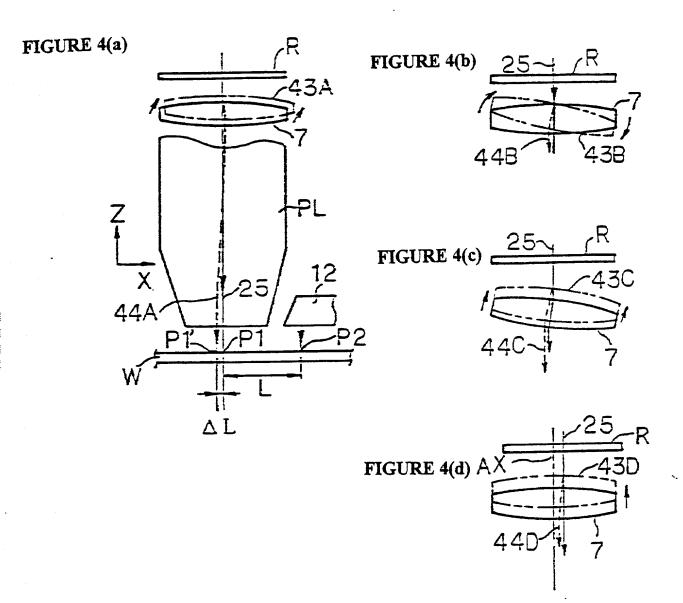


FIGURE 3





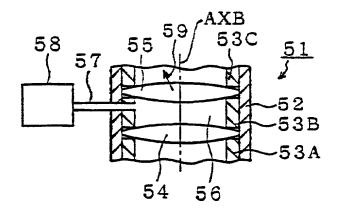
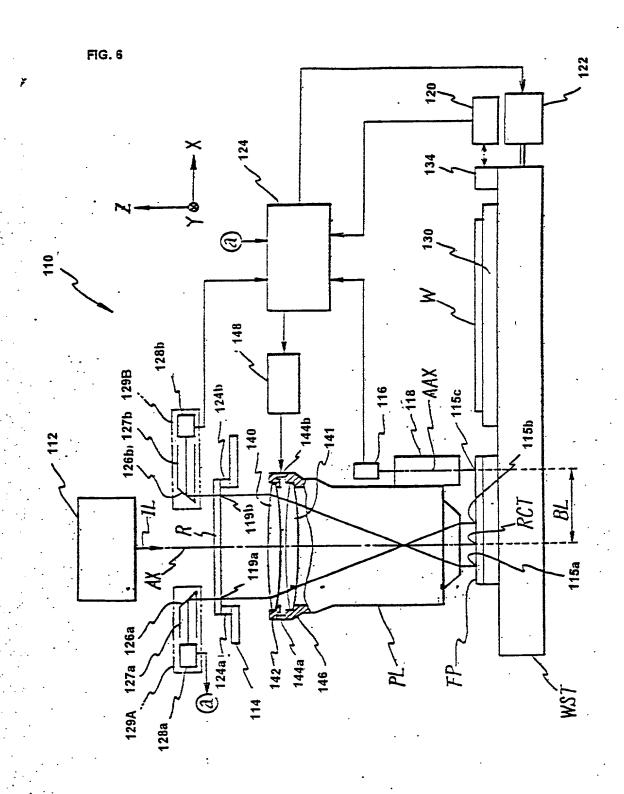
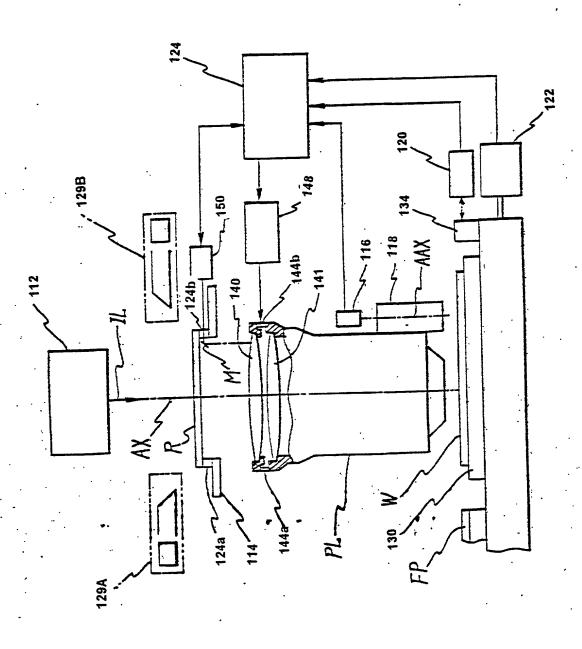


FIGURE 5





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